Tool ID: 316 Tool Location: 115

### **Equipment Information Sheet**

## **PVD 75 Sputter Deposition**

Manager:Aaron Windsor607-254-4831Calls to staff phones will be automatically forwarded to their cell phones during accessible hours. At other times leave a message or send them an email.

### **SAFETY**

- Be careful removing the platen.
- Be careful not to touch the heating lamps with the platen or your hands.
- The platen may still be warm if substrate heating was used. Wait a few minutes for the metal to cool at atmosphere.
- Do not use the metal evapo

# USAGE RESTRICTIONS SCHEDULING/SIGN-UP RESTRICTIONS

None

Minimum Tool Time: 30

minutes

## MATERIALS COMPATIBILITY CATEGORY

Tool Category 5: Class A and B Metals and Compounds	
Allowed	Not Allowed
Tool category 1/1E, 2, 3, and 4 materials	
Silicon Based Substrates and Films	
III/V compound Semiconductors	
Glass Substrates	
PECVD and ALD Films	
Cured organics and baked Photoresist	
CNF Class A, B, and Refractory metals	
Exposed Gold, Silver, Copper	
Alkali and Alkaline Compounds	
Organic/Biology Molecules prepared-w/salt buffers	
High Vapor Pressure Materials (Mg, Ca, Zn)*	* Some tool restrictions on high vapor pressure materials may apply
Soft organic materials	

High Vapor Pressure Metals and Compounds are materials that have a vapor pressure above 1e-6 Torr at 400 C.

### **Additional Material Restrictions and Exceptions**

None

Last Updated: 09/05/2019